ILC E-Driven e+ Source Hardware R&D of the Rotation Target and Rerated Areas in the last year



Works by Rigaku, Iwate Prefectural Industrial Technology Center, Kondo Equipment Co., Ltd., Iwate Industry Promotion Center, Iwate University/Tohoku University, Hiroshima University, Waseda University, Metal Technology Co., Ltd., TOHOKU SEIMITSU CO., LTD., and KEK 17-January-2022 IDT WG2, Source Group, Fully Remote presented by T. Omori (KEK)

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E-driven ILC Positron Source



- · 20 of 0.48us pulses are handled with NC linacs operated in 300Hz.
- 100 of 300 pulses are actually fired.

Today's Topics

(1) Prototype #2 with Dummy Disk The weight and the moment of the dummy disk is as same as the real target. Vacuum test with rotation.

(2) Evaporation Pan Test

Put ferrofluid in an evaporation pan. Then put the pan in a vacuum chamber and make residual gas analysis.

(3) Prototype #1 with Irradiated Ferrofluid. Irradiated ferrofluid is used in the prototype #1. Vacuum test with rotation.

(4) Cooling design of the immediate down stream of the target The collimator, the flux concentrator, and the first accelerating tube and are in severe thermal environment. Cooling design and hardware test are on going.









(1) Vacuum test with Rotation Prototype #2 with Dummy Disk



photo: Prototype #2 with Dummy Disk, at RIGAKU Workshop, Tokyo.

Rotation Target

- W-Re 16mm thick.
- 5 m/s tangential speed rotation (225 rpm, 0.5m diameter) in vacuum.



ferrofluid

Dummy Disk Added, February 2021. Vacuum Test with Rotation Started from April 2021.



We added the dummy target disk.at RIGAKU workshopAssembling at KEKJan. 2021Feb.-Mar. 2021

Fabrication at RIGAKU workshop Jan. 2021













Prototype #2 with Dummy Disk Experimental Procedures

Make pumping at both main chamber and intermediate point from the beginning.



Vacuum Data : From 9th April to 29th July, 2021



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Vacuum Data : From 9th April to 29th July, 2021



Vacuum Data, Enlarged Plot : From 24th July to 29th July, 2021



Date

- We achieved 7x10⁻⁷ Pa with dummy disk.
- Spike appears again. But height is small (*1.5).



photo: Evaporation pan in the vacuum chamber at KEK, Tsukuba.

Aim.

Assuming that the polymer of the ferrofluid decomposes into small molecules (CH-based molecules), determine the upper limit of the amount that will be come out as gas.

* Vacuum Test with Rotation (Prototype #1)



CAUTION:

We do NOT claim that the polymer of the ferrofluid decomposes into small molecules.

(1) Put ferrofluid in an evaporating pan. (2) Put the pan in a vacuum chamber. (3) Close the vessel with a lid. (4) Rough pumping without baking (reason of NOT baking: to protect the ferrofluid). (5) Then turn on ion pump.



Detach prototype#1 from the test bench, then put ferrofluid in a vacuum chamber.





Residual Gas Analysis after 22 days of pumping by Ion pump.

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Residual Gas Analyser

Vcos wt

±υ

Principle



Mass Pattern

電子衝撃による気体の電離および解離の研究

I. クラッキング・バターンの安定度, 電離確率, および電離能率曲線 (その1)

早川晃雄*·杉浦俊男**

(1955 年 7 月 22 日 受理)

第1表 クラッキング・パターンの安定度

(電子加速電圧, 100V; 全電子電流, 200 µA; イオン加速電圧. 1300V)

試 料	M/e	1 オ	У	クラッキング・パタ ーン (平均値)	平均偏差	同,%	測定回数
	13.3	A+++		0.041			
	20	A++		12.54	0.23	1.8	
Α	36	36A+		0.308			41
	38	38A+		0.061			1 N
	40	A+ ·		100	- '	-	
	14	N+(N ₂ ++)		17.3	0. 31	1, 8	
N_2	28	N2 ⁺		100		-	19
	29	15NN+		0. 75			
	16	0+		28.2	0.47	1,6	
O2	32	O2+		100	_	-	7
	34	16OO+		0.41			
	1	H+		2.82	0.04	1.4	16
H ₂	2	H ₂ +		100	-	-	

Summary of Analysis

Mass	Results of	Molecule Assignment						
Number	Measurement (Amps.)	H ₂	CH ₄	H ₂ O	N ₂ + CO	02	CO2	Unknown
1	9.51e-13	9.51e-13	0	0	0	0	0	0
2	6.11e-11	6.11e-11	2.46e-14	0	0	0	0	0
12	7.17e-13	0	8.12e-14	0	0	0	6.53e-14	5.67e-13 (*)
14	6.69e-13	0	1.61e-13	0	0	0	0	5.08e-13 (*)
15	8.09e-13	0	8.09e-13	0	0	0	0	0
16	2.48e-12	0	9.45e-13	0	0	8.54e-14	7.24e-14	1.38e-12 (*)
17	3.33e-12	0	1.04e-14	1.54e-12	0	0	0	1.79e-12 (*)
18	7.27e-12	0	0	7.27e-12	0	0	0	0
22	1.50e-14	0	0	0	0	0	1.43e-14	0
28	8.31e-12	0	0	0	8.24e-12	0	7.39e-14	0
29	2.22e-13	0	0	0	2.22e-13	0	0	0
32	3.03e-13	0	0	0	0	3.03e-13	0	0
34	0	0	0	0	0	0	0	0
44	7.54e-13	0	0	0	0	0	7.54e-13	0
45	1.42e-15	0	0	0		0	1.42e-15	0
Amps. of each molecule	-	6.21e-11	2.03e-12	8.81e-12	8.46e-12	3.88e-13	9.81e-13	4.25e-12
Sum of others	8.46e-13(**)	-	-	-	-	-	-	-

A sort of simultaneous linear equations, but not complete.

Evaporation Pan Test Summary of Analysis

*** RGA Current of Each Molecule (Amps.)**

H_2	6.21e-11
CH ₄	2.03e-12
H ₂ O	8.81e-12
N ₂ +CO	8.46e-12
O_2	3.88e-13
CO	9.81e-13

In order to be on the safe side in the following discussions, the XCH classification was established.

XCH Identified as CH₄ + Unkowns(*) of Mass(12)(14)(16)(17) + Sum of Others (**)

XCH 7.12e-12

* Total RGA Current 8.973e-11

* Total Pressure (Measured by Ionization Gauge) 9.27e-7 Pa

Analyze Residual Gas after 22 days of pumping by Ion pump.

Total Pressure	9.27e-7 Pa	note: All pressures are shown in nitrogen equivalent
Partial Pressure		
H_2	6.41e-7 Pa	
ХСН	7.36e-8 Pa	
H_2O	9.25e-8 Pa	
N_2 +CO	8.74e-8 Pa	
O_2	4.01e-9 Pa	
CO_2	1.01e-8 Pa	

What is XCH

- In order to be on the safe side in the following discussions, the XCH classification was established.
- XCH: Identified as CH4, plus unknown components including other hydrocarbons and unknown components arising from analysis (including errors).
- XCH is an estimate of the upper limit of hydrocarbon molecules from a pragmatic point of view.

Surface Area of Evaporation Pan $7 \ge 10^{-4} \mbox{ m}^2$ (Diameter of Evaporation Pan = 3 cm)Ion Pump Capacity $100 \mbox{ L/s} (=100 \mbox{ s}10^{-3} \mbox{ m}^3/\mbox{sec})$

"Evaporation" Rate per Unit Area of XCH determined by Evaporation Pan Test (7.36e-8 Pa)x(100x10⁻³ m³/sec)/(7 x 10⁻⁴m²) = (7.36e-9 Pa m³/sec)/(7 x 10⁻⁴m²) = 1.1e-5 Pa m/sec

In the real target, ferrofluid is a ring which diameter is 3 cm and width is 100 micron, if you see it from the vacuum chamber.

The surface area of it: $3.14 \ge 0.3 \le 100 \le 10^{-6} \le 1 \le 10^{-5} \le 10^{-5}$

XCH "Evaporation" Rate in the Real Target. 1.1e-10 Pa m³/sec

Model to Calculate XCH Partial Pressure at Acc. Tube





Upper limit of CH-based gas at upstream end of the accelerating tube: 1.5x10⁻¹⁰ Pa. We judge it is reasonably safe, according to the past experiences.

(3) Vacuum test with Rotation Prototype #1 with Irradiated Ferrofluid

photo: Prototype #1

Prototype #1 with 4.7 MGy irradiated ferrofluid.

Replace to 4.7 MGy irradiated ferrofluid (ILC 2600 bunch x 3 years)

Prototype #1 with 4.7 MGy irradiated ferrofluid September 2020 to July 2021

Prototype #1 with 4.7 MGy irradiated ferrofluid September 2020 to July 2021

Vacuum level 3.3E-6 Pa We achieved ~E-6 Pa with irradiated ferrofluid It is good in practical point of view.

But

Not as good as the best value 6E-7 Pa in past (Nov. 2017) Why?

Why?

- Irradiated fluid?
- Ion pump is aged?
- Humidity in air side of body is high (10 20%)?
- Other reason ?

(4) Cooling design of Immediate Downstream of Target

E-driven ILC Positron Source

- · 20 of 0.48us pulses are handled with NC linacs operated in 300Hz.
- 100 of 300 pulses are actually fired.

Heat Load at Target and it's Immediate Downstream

note : Each number is subject to reevaluate and is possibly changed.

What to do

The collimator, the flux concentrator, and the first accelerating tube are located at immediate downstream of the target. They are directly hit by the electromagnetic shower and are in severe thermal environment.

The flux concentrator and the first accelerating tube also generate heat by themselves.

We are going to solve the "Cooling design of Immediate Down Stream of Target" by Industry, Local Government, and Academia cooperation.

Iwate Prefectural Industrial Technology Center, Kondo Equipment Co. Ltd., Iwate Industry Promotion Center, Iwate University/Tohoku University, Hiroshima University, Metal Technology Co. Ltd., TOHOKU SEIMITSU CO. LTD., and KEK

Participating companies / organizations Locations and characteristics

Iwate Prefectural Industrial

"Contribute to the community" in terms of both industrial promotion and solving prefectural government issues. Provide technical support to companies.

TOHOKU SEIMITSU

Bonding methods (welding, diffusion bonding, vacuum brazing, friction welding, Spark Plasma Sintering,,,,)

Iwate Industry Promotion Center

To support promotion of industry in Iwate, cooperating with the government, Iwate prefectural government, Commerce-andindustry organizations, and research institutes.

Kondo Equipment Co., Ltd.

piping in general, air conditioning systems, heating and cooling systems, sanitary facilities, fire extinguishing systems, piping for large plants, prefabrication piping system with 3D-laser-measurement with 3D-CAD

National Stadium

TOHOKU SRF

Collimator : an example of ongoing studies

Collimator : an example of ongoing studies

note : Collimator is a passive device. Heat is generated by EM shower alone.

FC : an example of ongoing studies Single turn FC D16 mm Pavel 1

Pavel MARTYSHKIN et al. Budker INP 2016-2 KEK Preprint 2015-65

FC : example of ongoing study

note : Heat both by EM shower and by ohmic loss are considered in the study.

3D-printing model

velocity	2	5	m/s
Max Temp.	75	60	°C
Ave. Temp.	49	37	°C

Modular Design model (3 modules)

velocity	2	5	m/s
Max Temp.	77	65	°C
Ave. Temp.	46	38	°C

Capture Cavity (the first acc. tube): an example of ongoing studies

note : Heat only by EM-shower is considered in the study. To add the RF loss will be the next step.

We made a mock-up of the collimator by Hot Isostatic Pressing (HIP)

We made a mock-up of the collimator by HIP

A 7 kW heater will be used to give heat at inner surface

The heater was made budget of Iwate Univ. 40

Encapsulated parts are bonded by HIP process

Diffusion Bonding by HIP

Hot Isostatic Pressing(HIP)

Diffusion bonding, which was difficult with the conventional method, is possible in an environment of high temperature and high pressure (1000 kg / cm2 = over 98 MPa).

Image diagrams of Isostatic and Uniaxial pressing

Diffusion bonding of Dissimilar metals(Cu-SUS, Ti-SUS, Cu-carbon steel)
Bonding for all surface directions (Isostatic)
Three-dimensional shape (No remarkable deformation in one direction)
High temperature strength without brazing material.

金属技研・長澤氏 ILCX 2021 スライド

HIP machine in Metal Technology Co.

写真は金属技研 HP より借用

The Mockup under construction in Ibaraki Plant of Metal Technology Co.

Preparation of the cooling test by the mock-up.

On December 6th, the chiller unit was transported to Iwate by a truck of Kondo Equipment Co.

Cooling System constructed in Kondo Equipment Co.

Summary

Prototype #2 with Dummy Disk

Evaporation Pan Test

Prototype #1 with Irradiated Ferrofluid Cooling design of downstream of the Target

Summary

1. Prototype #2 with Dummy Disk: Vacuum test with Rotation

- We added the dummy disk on the prototype #2.
- We achieved 7x10⁻⁷ Pa with dummy disk.
- Spike appears again. But the height is small (x1.5).

2. Evaporation Pan Test

- Put ferrofluid in an evaporating pan and put it in the vacuum chamber.
- From the residual gas analysis data, the upper limit of the CH-based gas in the 1st accelerator tube is estimated to be 1.5x10⁻¹⁰ Pa.

3. Prototype #1 with Irradiated Ferrofluid: Vacuum test with Rotation

- 4.7 MGy irradiated ferrofluid is used in the prototype #1.
- We achieved 3.3x10⁻⁶ Pa. A good vacuum.

4. Cooling Design of Immediate Downstream of the Target

• The collimator, the flux concentrator, and the first accelerating tube are located at the immediate downstream of the target, and are in severe thermal environment. Cooling design and hardware test are on going.

